03500.014776



## PATENT APPLICATION

Date of Signature

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	Examiner: Hai Vo
HIROKATSU MIYATA	
Application No.: 09/657,616	: Group Art Unit: 1771 )
Filed: September 8, 2000  For: MESOSTRUCTURED THIN FILM, MESOPOROUS THIN FILM, AND PROCESS FOR PRODUCTION THEREOF	: ) : ) : October 12, 2005
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	
AMEN	<u>DMENT</u>
Sir:	
a) <u>Introductory Comments</u>	
In response to the Official Act	tion dated July 12, 2005, kindly amend the
subject application under as follows:	•
	I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on  October 12, 2005  (Date of Deposit)  PETER SAXON (Reg. No. 24,947)  (Name of Attorney for Applicant)